

# Soonkyu Je

## List of Publications by Year in descending order

Source: <https://exaly.com/author-pdf/299850/publications.pdf>

Version: 2024-02-01

2  
papers

13  
citations

2682572

2  
h-index

2917675

2  
g-index

2  
all docs

2  
docs citations

2  
times ranked

18  
citing authors

#	ARTICLE	IF	CITATIONS
1	Real-Time Compensation of Simultaneous Errors Induced by Optical Phase Difference and Substrate Motion in Scanning Beam Laser Interference Lithography System. IEEE/ASME Transactions on Mechatronics, 2018, 23, 1491-1500.	5.8	8
2	Development of Direct Deep Reactive Ion Etching Process Using Laser Interference Lithographed Etch Barrier without Intermediate Layer. Japanese Journal of Applied Physics, 2013, 52, 10MC04.	1.5	5